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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10007618	FILING DATE 11/07/2001	CLASS 438	SUBCLASS 217?	GAU 2652 2812	EXAMINER Bratlie TIAN
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**APPLICANTS: Casa Neil;

**CONTINUING DATA VERIFIED: NONE (TWT)

** FOREIGN APPLICATIONS VERIFIED: NONE (TWT)

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO 00245/TL
Verified and Acknowledged Examiner's initials <i>TWT</i>		
TITLE : System and method for inhibiting motion of semiconductor wafers in a variable-pressure chamber		

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
Amount Due	Date Paid		Total Claims	Print Claim for O.G.
		DRAWING		
		Sheets Drwg.	Figs.Drwg.	Print Fig.
		Primary Examiner		
		PREPARED FOR ISSUE		
		Application Examiner		
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